L Number	Hits	Search Text	DB	Time stamp
-	2	float and zervigon.xa.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/02/06 10:26
-	26067	float$ same (wafer or substrate)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/08/20 17:26
-	596507	(((c23c016$.ipc. or c23c014$.ipc. or h01l021$.ipc or c23f01$.ipc.) or ((156/$).CCLS. OR (118/$).CCLS. OR (438/$).CCLS. OR (427/$).CCLS. OR (219/$).CCLS.))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/08/20 17:29
-	5524	(float$ same (wafer or substrate)) and (((c23c016$.ipc. or c23c014$.ipc. or h01l021$.ipc or c23f01$.ipc.) or ((156/$).CCLS. OR (118/$).CCLS. OR (438/$).CCLS. OR (427/$).CCLS. OR (219/$).CCLS.)))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/08/21 10:25
-	21	((float$ same (wafer or substrate)) and (((c23c016$.ipc. or c23c014$.ipc. or h01l021$.ipc or c23f01$.ipc.) or ((156/$).CCLS. OR (118/$).CCLS. OR (438/$).CCLS. OR (427/$).CCLS. OR (219/$).CCLS.)))) and "first electrode" and DC and AC	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/08/20 17:33
-	15	((float$ same (wafer or substrate)) and (((c23c016$.ipc. or c23c014$.ipc. or h01l021$.ipc or c23f01$.ipc.) or ((156/$).CCLS. OR (118/$).CCLS. OR (438/$).CCLS. OR (427/$).CCLS. OR (219/$).CCLS.)))) and "upper electrode" and DC and AC not (((float$ same (wafer or substrate)) and (((c23c016$.ipc. or c23c014$.ipc. or h01l021$.ipc or c23f01$.ipc.) or ((156/$).CCLS. OR (118/$).CCLS. OR (438/$).CCLS. OR (427/$).CCLS. OR (219/$).CCLS.)))) and "first electrode" and DC and AC)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/08/20 17:40
-	28	((float$ same (wafer or substrate)) and (((c23c016$.ipc. or c23c014$.ipc. or h01l021$.ipc or c23f01$.ipc.) or ((156/$).CCLS. OR (118/$).CCLS. OR (438/$).CCLS. OR (427/$).CCLS. OR (219/$).CCLS.)))) and (electrode same (DC and AC)) not ((((float$ same (wafer or substrate)) and (((c23c016$.ipc. or c23c014$.ipc. or h01l021$.ipc or c23f01$.ipc.) or ((156/$).CCLS. OR (118/$).CCLS. OR (438/$).CCLS. OR (427/$).CCLS. OR (219/$).CCLS.)))) and "first electrode" and DC and AC) or (((float$ same (wafer or substrate)) and (((c23c016$.ipc. or c23c014$.ipc. or h01l021$.ipc or c23f01$.ipc.) or ((156/$).CCLS. OR (118/$).CCLS. OR (438/$).CCLS. OR (427/$).CCLS. OR (219/$).CCLS.)))) and "upper electrode" and DC and AC not (((float$ same (wafer or substrate)) and (((c23c016$.ipc. or c23c014$.ipc. or h01l021$.ipc or c23f01$.ipc.) or ((156/$).CCLS. OR (118/$).CCLS. OR (438/$).CCLS. OR (427/$).CCLS. OR (219/$).CCLS.)))) and "first electrode" and DC and AC)))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/08/20 17:53

-		81	((float$ same (wafer or substrate)) and (((c23c016$.ipc. or c23c014$.ipc. or h01l021$.ipc or c23f01$.ipc.) or ((156/$).CCLS. OR (118/$).CCLS. OR (438/$).CCLS. OR (427/$).CCLS. OR (219/$).CCLS.)))) and (electrode and (DC and AC)) not ((((float$ same (wafer or substrate)) and (((c23c016$.ipc. or c23c014$.ipc. or h01l021$.ipc or c23f01$.ipc.) or ((156/$).CCLS. OR (118/$).CCLS. OR (438/$).CCLS. OR (427/$).CCLS. OR (219/$).CCLS.)))) and "first electrode" and DC and AC) or ((float$ same (wafer or substrate)) and (((c23c016$.ipc. or c23c014$.ipc. or h01l021$.ipc or c23f01$.ipc.) or ((156/$).CCLS. OR (118/$).CCLS. OR (438/$).CCLS. OR (427/$).CCLS. OR (219/$).CCLS.)))) and "upper electrode" and DC and AC not ((((float$ same (wafer or substrate)) and (((c23c016$.ipc. or c23c014$.ipc. or h01l021$.ipc or c23f01$.ipc.) or ((156/$).CCLS. OR (118/$).CCLS. OR (438/$).CCLS. OR (427/$).CCLS. OR (219/$).CCLS.)))) and "first electrode" and DC and AC) or ((float$ same (wafer or substrate)) and (((c23c016$.ipc. or c23c014$.ipc. or h01l021$.ipc or c23f01$.ipc.) or ((156/$).CCLS. OR (118/$).CCLS. OR (438/$).CCLS. OR (427/$).CCLS. OR (219/$).CCLS.)))) and (electrode same (DC and AC)) not ((((float$ same (wafer or substrate)) and (((c23c016$.ipc. or c23c014$.ipc. or h01l021$.ipc or c23f01$.ipc.) or ((156/$).CCLS. OR (118/$).CCLS. OR (427/$).CCLS. OR (219/$).CCLS.)))) and "first electrode" and DC and AC) or ((float$ same (wafer or substrate)) and (((c23c016$.ipc. or c23c014$.ipc. or h01l021$.ipc or c23f01$.ipc.) or ((156/$).CCLS. OR (118/$).CCLS. OR (438/$).CCLS. OR (427/$).CCLS. OR (219/$).CCLS.)))) and "upper electrode" and DC and AC not ((((float$ same (wafer or substrate)) and (((c23c016$.ipc. or c23c014$.ipc. or h01l021$.ipc or c23f01$.ipc.) or ((156/$).CCLS. OR (118/$).CCLS. OR (438/$).CCLS. OR (427/$).CCLS. OR (219/$).CCLS.)))) and "first electrode" and DC and AC)))))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/08/20 18:03
-		172	("floating wafer" or "floating substrate") and (((c23c016$.ipc. or c23c014$.ipc. or h01l021$.ipc or c23f01$.ipc.) or ((156/$).CCLS. OR (118/$).CCLS. OR (438/$).CCLS. OR (427/$).CCLS. OR (219/$).CCLS.)))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/08/20 18:04
-		76	(("floating wafer" or "floating substrate") and (((c23c016$.ipc. or c23c014$.ipc. or h01l021$.ipc or c23f01$.ipc.) or ((156/$).CCLS. OR (118/$).CCLS. OR (438/$).CCLS. OR (427/$).CCLS. OR (219/$).CCLS.)))) and electrode	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/08/20 18:04
-		0	5980687.pn. and bias	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/08/21 08:58
-	-	2	5980687.pn.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/08/21 10:25
-	-	5524	(float$ same (wafer or substrate)) and (((c23c016$.ipc. or c23c014$.ipc. or h01l021$.ipc or c23f01$.ipc.) or ((156/$).CCLS. OR (118/$).CCLS. OR (438/$).CCLS. OR (427/$).CCLS. OR (219/$).CCLS.)))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/08/21 10:29
-		1366	((float$ and potential) same (wafer or substrate)) and (((c23c016$.ipc. or c23c014$.ipc. or h01l021$.ipc or c23f01$.ipc.) or ((156/$).CCLS. OR (118/$).CCLS. OR (438/$).CCLS. OR (427/$).CCLS. OR (219/$).CCLS.)))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/08/21 10:51
-		0	(((float$ and potential) same (wafer or substrate)) and (((c23c016$.ipc. or c23c014$.ipc. or h01l021$.ipc or c23f01$.ipc.) or ((156/$).CCLS. OR (118/$).CCLS. OR (438/$).CCLS. OR (427/$).CCLS. OR (219/$).CCLS.)))) and AC and DC and "zero bias"	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/08/21 10:52
-		4	(((float$ and potential) same (wafer or substrate)) and (((c23c016$.ipc. or c23c014$.ipc. or h01l021$.ipc or c23f01$.ipc.) or ((156/$).CCLS. OR (118/$).CCLS. OR (438/$).CCLS. OR (427/$).CCLS. OR (219/$).CCLS.)))) and "zero bias"	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/08/21 10:52

-	111	(((float$ and potential) same (wafer or substrate)) and (((c23c016$.ipc. or c23c014$.ipc. or h01l021$.ipc or c23f01$.ipc.) or ((156/$).CCLS. OR (118/$).CCLS. OR (438/$).CCLS. OR (427/$).CCLS. OR (219/$).CCLS.)))) and AC and DC	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/08/21 11:51
-	24	((((float$ and potential) same (wafer or substrate)) and (((c23c016$.ipc. or c23c014$.ipc. or h01l021$.ipc or c23f01$.ipc.) or ((156/$).CCLS. OR (118/$).CCLS. OR (438/$).CCLS. OR (427/$).CCLS. OR (219/$).CCLS.)))) and AC and DC) and switch	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/08/21 11:56
-	2	5897752.pn.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/08/21 11:56
-	6	(("5316646") or ("5316645") or ("5202008") or ("5114556") or ("4038171") or ("3410775")).PN.	USPAT	2002/08/21 11:59
-	87	((((float$ and potential) same (wafer or substrate)) and (((c23c016$.ipc. or c23c014$.ipc. or h01l021$.ipc or c23f01$.ipc.) or ((156/$).CCLS. OR (118/$).CCLS. OR (438/$).CCLS. OR (427/$).CCLS. OR (219/$).CCLS.)))) and AC and DC) not (((((float$ and potential) same (wafer or substrate)) and (((c23c016$.ipc. or c23c014$.ipc. or h01l021$.ipc or c23f01$.ipc.) or ((156/$).CCLS. OR (118/$).CCLS. OR (438/$).CCLS. OR (427/$).CCLS. OR (219/$).CCLS.)))) and AC and DC) and switch)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/08/21 12:00
-	168	((((float$ and potential) same (wafer or substrate)) and (((c23c016$.ipc. or c23c014$.ipc. or h01l021$.ipc or c23f01$.ipc.) or ((156/$).CCLS. OR (118/$).CCLS. OR (438/$).CCLS. OR (427/$).CCLS. OR (219/$).CCLS.)))) and switch not (((((float$ and potential) same (wafer or substrate)) and (((c23c016$.ipc. or c23c014$.ipc. or h01l021$.ipc or c23f01$.ipc.) or ((156/$).CCLS. OR (118/$).CCLS. OR (438/$).CCLS. OR (427/$).CCLS. OR (219/$).CCLS.)))) and AC and DC) and switch)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/08/21 14:02
-	2	6220201.pn.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/08/21 14:25
-	9	(("6033482") or ("6406925") or ("5942042") or ("6346428") or ("5897752") or ("6379576") or ("6237527") or ("6220201") or ("5980687") or ("5980687")).PN.	USPAT	2002/08/21 14:25
-	2	5980687.pn.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/02/06 10:39
-	1	us-20030017709-$.did.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/02/06 12:06
-	3265	(wafer or substrate) same (conduction and interface)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/02/06 12:07
-	1271	(wafer or substrate) with (conduction and interface)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/02/06 12:08
-	78	(wafer or substrate) with (conduction and interface and roughness)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/02/06 12:14
-	1	us-20030017709-$.did.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/02/06 12:22

-	2	5810933.pn.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/02/06 13:12
-	2	5980687.pn.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/02/06 13:53
-	1974	((HF and LF) or ((high-frequency or "high frequency") and (low-frequency or "low frequency"))) and plasma and (electrode or anode or cathode)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/02/06 13:57
-	1113	(((HF and LF) or ((high-frequency or "high frequency") and (low-frequency or "low frequency"))) and plasma and (electrode or anode or cathode)) and upper and lower	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/02/06 13:59
-	864	((((HF and LF) or ((high-frequency or "high frequency") and (low-frequency or "low frequency"))) and plasma and (electrode or anode or cathode)) and upper and lower) and (wafer or substrate)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/02/06 13:59
-	807	(((((HF and LF) or ((high-frequency or "high frequency") and (low-frequency or "low frequency"))) and plasma and (electrode or anode or cathode)) and upper and lower) and (wafer or substrate)) and power	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/02/06 14:00
-	403	((((((HF and LF) or ((high-frequency or "high frequency") and (low-frequency or "low frequency"))) and plasma and (electrode or anode or cathode)) and upper and lower) and (wafer or substrate)) and power) and khz and mhz	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/02/06 14:03
-	74	(((((((HF and LF) or ((high-frequency or "high frequency") and (low-frequency or "low frequency"))) and plasma and (electrode or anode or cathode)) and upper and lower) and (wafer or substrate)) and power) and khz and mhz) and (118/723e.ccls. or 156/345.43.ccls. or 156/345.44.ccls. or 156/345.46.ccls.)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/02/06 14:46
-	2	5810933.pn.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/02/06 14:46